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Application Number

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Applicant

Yee-Chia Yeo et al.

Filing Date

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Group Art Unit

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
103	5534713	7/9/96	Ismail et al.	257	24	5/20/94
	5019882	5/28/91	Solomon et al.	357	23.8	5/15/89
	6004137	12/21/99	Crabbé et al.	437	40	9/23/93
	5985703	11/16/99	Banerjee	438	162	5/13/96
	5241197	8/31/98	Murakami et al.	257	192	9/13/91
103	5981345	11/9/99	Ryum et al.	438	303	7/10/97

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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